Eronides Felisberto da Silva

List of Publications by Year in descending order

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933447 940533 18 445 10 16 citations g-index h-index papers 19 19 19 314 docs citations times ranked citing authors all docs

#	Article	IF	CITATIONS
1	Radiation Response of MOS Capacitors Containing Fluorinated Oxides. IEEE Transactions on Nuclear Science, 1987, 34, 1190-1195.	2.0	112
2	A novel fluorinated Eu(III) \hat{l}^2 -diketone complex as thin film for optical device applications. Optical Materials, 1998, 11, 23-28.	3.6	64
3	Two distinct interface trap peaks in radiationâ€damaged metal/SiO2/Si structures. Applied Physics Letters, 1987, 51, 270-272.	3.3	46
4	Fabrication of high quality silicon–polyaniline heterojunctions. Applied Surface Science, 2002, 190, 390-394.	6.1	45
5	Production of Ball-Lightning-Like Luminous Balls by Electrical Discharges in Silicon. Physical Review Letters, 2007, 98, 048501.	7.8	42
6	Equivalence between interface traps in SiO2/Si generated by radiation damage and hotâ€electron injection. Applied Physics Letters, 1988, 52, 720-722.	3.3	28
7	Radiation-Induced Interface Traps in Mo/SiO2/Si Capacitors. IEEE Transactions on Nuclear Science, 1987, 34, 1166-1171.	2.0	27
8	Nanowire growth on Si wafers by oxygen implantation and annealing. Applied Surface Science, 2006, 252, 5572-5574.	6.1	22
9	Tailoring the Electrical Properties of ZnO/Polyaniline Heterostructures for Device Applications. Journal of the Korean Physical Society, 2011, 58, 1256-1260.	0.7	14
10	Simulation of the early stages of thin film growth. Semiconductor Science and Technology, 1997, 12, 1038-1045.	2.0	12
11	Effects of trichloroethane during oxide growth on radiationâ€induced interface traps in Metal/SiO2/Si capacitors. Applied Physics Letters, 1987, 51, 1262-1264.	3.3	8
12	Electronic and magnetic properties of SnO2/CrO2 thin superlattices. Nanoscale Research Letters, 2011, 6, 146.	5.7	8
13	Radiationâ€induced enhancement of minorityâ€carrier lifetimes in metal/SiO2/Si capacitors having oxides grown in O2with trichloroethane additive. Applied Physics Letters, 1988, 53, 592-594.	3.3	5
14	Timeâ€dependent evolution of SiO2/Si interface traps after repeated radiation damage. Journal of Applied Physics, 1988, 64, 3317-3319.	2.5	5
15	Spin-polarization effects in homogeneous and non-homogeneous diluted magnetic semiconductor heterostructures. Nanotechnology, 2010, 21, 375401.	2.6	4
16	X-Ray Radiation Response of Epitaxial and Nonepitaxial n-6H–SiC Metal-Oxide-Semiconductor Capacitors. Japanese Journal of Applied Physics, 2001, 40, 2987-2990.	1.5	3
17	Study of the vertical transport in p-doped superlattices based on group III-V semiconductors. Nanoscale Research Letters, 2011, 6, 175.	5.7	0
18	Effect of H ₂ O ₂ in passivation of n―and pâ€ŧype 4H‧iC surfaces. Physica Status Solidi (A) Applications and Materials Science, 2012, 209, 675-678.	1.8	0